

ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1

Stylesheet Version v1.1.1

Title of Invention

COMPOSITION FOR AN ETCHING MASK COMPRISING A SILICON-CONTAINING MATERIAL

Submission Type : Information Disclosure Statement

Application Number:

10/789319



EFS ID:

82730

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First Named Applicant: Frank Xu

Attorney Docket Number: P121-63-03

Timestamp: 2005-04-22 10:06:50 EDT

From: us

File Listing:

Doc. Name	File Name	Size (Bytes)	Date Produced (yyyymmdd)
us-ids	P121_IDS-C-usidst.xml	3856	2005-04-22
us-ids	us-ids.dtd	7763	2005-04-22
us-ids	us-ids.xsl	12026	2005-04-22
package-data	P121_IDS-C-pkda.xml	1774	2005-04-22
package-data	package-data.dtd	27025	2005-04-22
package-data	us-package-data.xsl	19263	2005-04-22
Total files size		71707	

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